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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of

MICHAEL SHU-HUAN WANG ET AL.

Serial No. 10/718,921 (TI-34402)

Filed November 21, 2003

For: CHEMICAL-MECHANICAL POLISHING APPARATUS AND METHOD TO
MINIMIZE SLURRY ACCUMULATION AND SCRATCH EXCURSIONS

Art Unit 2399

Examiner SHANTESE L. McDONALD

Customer No. 23494

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8

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7-28-06

Jay M. Cantor, Reg. No. 19,906

AMENDMENT UNDER 37 C.F.R. 1.111

In response to the Office action dated June 2, 2006, please amend the above
identified application as follows: